



PATENT

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Date May 1, 2003

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Yekaterina Geyfman #9

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Vishnu K. Agarwal and  
Scott G. Meikle

Attorney Docket No.: 500453.04

Serial No. : 09/970,100

Group Art Unit : 1762

Filed : October 2, 2001

Examiner : William P. Fletcher, III

Title : POLISHING PADS AND PLANARIZING MACHINES FOR MECHANICAL  
OR CHEMICAL-MECHANICAL PLANARIZATION OF MICROELECTRONIC  
DEVICE SUBSTRATE ASSEMBLIES, AND METHODS FOR MAKING AND  
USING SUCH PADS AND MACHINES

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TC MAIL ROOM

**FILING FORMAL DRAWINGS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Enclosed are four sheets of formal drawings, Figures 1-8, for filing in the above-identified application.

Respectfully submitted,

Vishnu K. Agarwal and Scott G. Meikle

Date: 5/1/03

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Formal Drawings (4 Sheets, Figs. 1-8)